



INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)			ATTY DOCKET NO. ITL.1023US (P16710)	SERIAL NO. 10/679,816	
			APPLICANT(S) ROBERT BRISTOL ET AL.		
			FILING DATE: October 6, 2003	GROUP ART UNIT: 1756	

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
				430	325	
KAD	A. 5,158,861	10/27/1992	TOKUI ET AL.			
	B.					
	C.					
	D.					
	E.					
	F.					
	G.					
	H.					
	I.					

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	J.							
	K.							
	L.							
	M.							
	N.							
	O.							
	P.							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KAD	Q.	Cheng et al., "Improving Resist Resolution and Sensitivity Via Electric-Field Enhanced Postexposure Baking", J. Vac. Sci. Technol. B 20(2), Mar/Apr 2002
	R.	
	S.	
	T.	
	U.	
	V.	
	W.	

EXAMINER K. Duda	DATE CONSIDERED 3-6-06
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)			ATTY DOCKET NO. ITL.1023US (P16710)	SERIAL NO. 10/679,816
			APPLICANT(S): Robert Bristol et al.	
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
WAD	A. 5,648,000	07/15/1997	Yamazaki et al.	—	—	
WAD	B. 5,783,362	07/21/1998	Wakiya et al.	—	—	
WAD	C. 6,103,145	08/15/2000	Angelopoulos et al.	—	—	
	D.					
	E.					

U.S. PATENT APPLICATION PUBLICATIONS

WAD	F.	2002/0046703	04/25/2002	Templeton	—	—	
WAD	G.	2003/0008246	01/09/2003	Cheng et al.	—	—	
	H.						
	I.						
	J.						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
WAD	K.	JP 57-32632	02/22/1982	Japan	—	—	Abstract Only	
WAD	L.	JP 63-71842	04/01/1988	Japan	—	—	Abstract Only	
WAD	M.	JP 63-244622	10/12/1988	Japan	—	—	Abstract Only	
WAD	N.	JP 10-106930	04/24/1998	Japan	—	—	Abstract Only	
	O.							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

P.	
Q.	
R.	
S.	
T.	
U.	
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